APS Rec'd PCT/PTO 10 FEB 2006

ATTORNEY'S DOCKET NUMBER US DEPARTMENT OF COMMERCE PATENT & TRADEMARK OFFICE FORM PTO-1390 124796 (REV. 01-2003) U.S. APPLICATION NO. (If known, see 37 CFR 1.5) TRANSMITTAL LETTER TO THE UNITED STATES DESIGNATED/ELECTED OFFICE (DO/EO/US) 10/542.956 **CONCERNING A FILING UNDER 35 U.S.C. 371** PRIORITY DATE CLAIMED INTERNATIONAL FILING DATE INTERNATIONAL APPLICATION NO. January 21, 2003 January 16, 2004 PCT/JP2004/000265 THIN FILM CAPACITANCE ELEMENT COMPOSITION, HIGH PERMITTIVITY INSULATION FILM, THIN FILM CAPACITANCE TITLE OF INVENTION ELEMENT, THIN FILM MULTILAYER CAPACITOR AND PRODUCTION METHOD OF THIN FILM CAPACITANCE ELEMENT APPLICANT FOR DO/EO/US Yukio SAKASHITA Applicant herewith submits to the United States Designated/Elected Office (DO/EO/US) the following items and other information: This is a FIRST submission of items concerning a filing under 35 U.S.C. 371. 1. This is a **SECOND** or **SUBSEQUENT** submission of items concerning a filing under 35 U.S.C. 371. 2.  $\boxtimes$ This is an express request to begin national examination procedures (35 U.S.C. 371(f)). The submission must include 3. items (5), (6), (9) and (21) indicated below. The US has been elected (Article 31). 4. A copy of the International Application as filed (35 U.S.C. 371(c)(2)) 5. a.  $\square$  is attached hereto (required only if not communicated by the International Bureau). b.  $\square$  has been communicated by the International Bureau. ☐ An English language translation of the International Application as filed (35 U.S.C. 371(c)(2)) 6. a. 

is attached hereto. b. ☐ has been previously submitted under 35 U.S.C. 154(d)(4). c. 
 ☐ The International Application was filed in English. Amendments to the claims of the International Application under PCT Article 19 (35 U.S.C. 371(c)(3)) 7. b.  $\square$  have been communicated by the International Bureau. c. have not been made; however, the time limit for making such amendments has NOT expired. An English language translation of the amendments to the claims under PCT Article 19 (35 U.S.C. 371(c)(3)). 8. An oath or declaration of the inventor(s) (35 U.S.C. 371(c)(4)). 9. An English language translation of the annexes of the International Preliminary Examination Report under PCT Article 36 10. (35 U.S.C. 371(c)(5)). Items 11 to 20 below concern document(s) or information included: An Information Disclosure Statement under 37 CFR 1.97 and 1.98. 11. An assignment document for recording. A separate cover sheet in compliance with 37 CFR 3.28 and 3.31 is included. 12. A preliminary amendment. 13. An Application Data Sheet under 37 CFR 1.76. 14. A substitute specification. 15. A power of attorney and/or change of address letter. 16. A computer-readable form of the sequence listing in accordance with PCT Rule 13ter.2 and 37 CFR 1.821 - 1.825. 17. A second copy of the published international application under 35 U.S.C. 154(d)(4). 18. A second copy of the English language translation of the international application under 35 U.S.C. 154(d)(4). 19. Other items or information: International Search Report. 20.  $\boxtimes$ 

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yukio SAKASHITA

Application No.: 10/542,956

Filed: July 21, 2005 Docket No.: 124796

For: THIN FILM CAPACITANCE ELEMENT COMPOSITION, HIGH PERMITTIVITY INSULATION FILM, THIN FILM CAPACITANCE ELEMENT, THIN FILM

MULTILAYER CAPACITOR AND PRODUCTION METHOD OF THIN FILM

CAPACITANCE ELEMENT

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. Relevance of one or more non-English language reference is discussed in the present specification. See References 1-5.
- 3. One or more reference cited herein was cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information. See References 6-9 & 17.
- 4. An English language Abstract of one or more non-English language reference is attached hereto. See References 2-5 & 7-9.

- 5. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See References 2-5 & 7-9.
- 8. References 7 corresponds to Reference 6.

Respectfully submitted,

Mandi M Drs

James A. Oliff

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JAO:RBI/yxm

Date: February 10, 2006

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE
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(Use several sheets if necessary)			APPLICANT Yukio SAKASHITA			<u>.</u>			
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		U.	S. PATEN	T DOCUM	1ENTS				
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		FORE	EIGN PATI	ENT DOC	UMENTS				
Examiner Initials	Cite No.	Document Number	Da	ite	Country		With English Abstract	With English Translation	
	1	JP A 56-144523	11/10/19	81	JAPAN				
	2	JP A 05-335173	12/17/19	93	JAPAN		х	х	
	3	JP A 05-335174	12/17/19	93	JAPAN		х	х	
	4	JP A 11-214245	08/06/19	199	JAPAN		x	х	
	5	JP A 2000-124056	04/28/20	000	JAPAN		х	х	
	6	EP 0 877 100 A1	11/11/19	98	EUROPEAN PATENT OFFIC	E.			
	7	JP A 11-049600	02/23/19	99	JAPAN		Х	х	
	8	JP A 08-253324	10/01/19	996	JAPAN		Х	х	
	9	JP A 2002-321974	11/08/20	002	JAPAN		х	х	
			OTHER E	OCUME	NTS				
Examiner Cite (Including Author, Title, Date, Pertinent Pages, etc.) Initials No.									
	10	T. KOJIMA et al., "Novel Candidate of c-axis-oriented BLSF Thin Films for High-Capacitance Condenser," Mat. Res. Soc. Symp. Proc., 2003, Vol. 748, pages 451-456.							
	11	The 27 <sup>th</sup> Annual Cocoa Beach Conference & Exposition on Advance Ceramics & Composites, 26-31 January 2003							
	12	The 5 <sup>th</sup> International Meeting of Pacif Japan, 29 September to 2 October 200		ramic Soci	ieties Incorporating the 16 <sup>th</sup> Fall	Meeting of	the Ceramic S	ociety of	
	13	The 5 <sup>th</sup> International Meeting of Pacifi Japan, 2003, page 111	c Rim Cer	amic Socie	eties Incorporating the 16 <sup>th</sup> Fall N	Aeeting of	the Ceramic S	ociety of	
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II	NFORMAT	ION DISCLOSURE STATEMENT							
	(Use several sheets if necessary)			APPLICANT Yukio SAKASHITA					
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	<u></u>	U.S. PAT	ENT	DOCUM	ENTS				
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		FOREIGN F	PATE	NT DOC	CUMENTS				
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	14	MRS 2002 Program Exhibit Guide, 2-6 Dec	cemb	er 2002, p	page 211				
Extended Abstracts (The 50 <sup>th</sup> Spring Meeting, 2003); The Japan Society of Applied Physics and I March 2003, page 596							ated Societies,	No. 2, 27-30	
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	17	L. NIBOU et al., Chemical Fabrication SrBi <sub>4</sub> Ti <sub>4</sub> O <sub>15</sub> Thin Films, Journal of the European Ceramic Society, 1999, Vol. 19, pages							
		1383 to 1386							
EXAMINER						DATE	CONSIDERE	ED.	
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Date: February 10, 2006